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EXAMINER

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ART UNIT	PAPER NUMBER
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1795

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PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Office Action Summary	Application No.		Applicant(s)	
	10/027,484		BOHM ET AL.	
	Examiner		Art Unit	
	Jeffrey T. Barton		1795	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --
Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 07 August 2008.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1-14, 16-45, 47-64 and 66-70 is/are pending in the application.
- 4a) Of the above claim(s) 2-8, 22-41, 49-54, 59, 60 and 67-69 is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 1, 9-14, 16-21, 42-45, 47, 48, 55-58 61-64, 66, and 70 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
2. ☐ Certified copies of the priority documents have been received in Application No. _____.
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- | | |
|--|---|
| 1) <input type="checkbox"/> Notice of References Cited (PTO-892) | 4) <input type="checkbox"/> Interview Summary (PTO-413) |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948) | Paper No(s)/Mail Date. _____ |
| 3) <input type="checkbox"/> Information Disclosure Statement(s) (PTO/SB/08) | 5) <input type="checkbox"/> Notice of Informal Patent Application |
| Paper No(s)/Mail Date _____ | 6) <input type="checkbox"/> Other: _____ |

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 7 August 2008 has been entered.

Response to Amendment

2. The amendment filed on 7 August 2008 does not place the application in condition for allowance.

Status of Rejections Pending Since the Office Action of 7 February 2008

3. The rejections of claims 9-14 and 16-21 under 35 U.S.C. §112, second paragraph are withdrawn due to Applicant's amendments.
4. All other rejections are maintained.

Claim Rejections - 35 USC § 112

5. The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

6. Claims 1, 9-14, 16-21, 42-45, 47, 48, 55-58, 61-64, 66, and 70 are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the written description requirement. The claim(s) contains subject matter which was not described in the specification in such a way as to reasonably convey to one skilled in the relevant art that the inventor(s), at the time the application was filed, had possession of the claimed invention. There is no explicit disclosure of a method of injecting a liquid into a microchannel that is filled with a first fluid such that "such that none of the first fluid [in/from] the microchannel enters the fluid interface port" (Claims 1, 42, 64, 66, and 70) in the specification as originally filed, nor is there explicit disclosure of a method of filling a microchannel with a liquid "wherein none of the liquid in the microchannel enters the fluid interface port when the microchannel is filled with liquid" (Claim 9) or "wherein none of the first liquid fills the first filling aperture and none of the second liquid fills the second filling aperture when the microchannel is filled with the first liquid and the second liquid". (Claim 20) Dead volume that is "most preferably about zero" is disclosed (Page 22, lines 15-17), but a dead volume that is preferably "about zero" is not equivalent to the complete exclusion of liquid from the port or filling aperture now claimed.

Claim Rejections - 35 USC § 103

7. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the

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invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

8. The factual inquiries set forth in *Graham v. John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:

1. Determining the scope and contents of the prior art.
2. Ascertaining the differences between the prior art and the claims at issue.
3. Resolving the level of ordinary skill in the pertinent art.
4. Considering objective evidence present in the application indicating obviousness or nonobviousness.

9. This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

10. Claims 1, 42, 47, 48, 56-58, 61-64, 66, and 70 are rejected under 35 U.S.C. 103(a) as being unpatentable over Heller et al (WO 99/64850) in view of either McCormick et al or Amigo. Since WO 99/64850 is in German, citations below are given to US Patent No. 6,846,398, which issued from the National Stage entry of this International Application.

Regarding claims 1, 42, 64, 66, and 70 Heller et al disclose a method of injecting a second liquid into a microchannel filled with a first liquid comprising: forming a droplet

from the second liquid and directing the droplet to, and introducing it through a virtual wall formed by the first fluid in a fluid interface port (Figure 2, port A) formed in a sidewall of the microchannel. (Column 6, lines 1-28; menisci that inherently form at the areas A after filling with buffer correspond to the “virtual walls”) The menisci of the first liquid lie in a plane shared by the sidewall and can therefore be described as “substantially coplanar”. Heller et al disclose ports A with diameters ranging from twenty to several hundred microns. (Column 4, lines 61-62; Column 6, lines 1-2; ports are shown as being as wide as the channels in Figure 2) The ports must inherently have a depth equal to the thickness of the sidewall.

Regarding claim 48, Heller et al disclose the droplet traversing the virtual wall. (Column 6, lines 20-28; inherent in the loading step) As such, its speed and direction must be appropriate.

Regarding claims 56 and 57, Heller et al disclose motion of the injected fluid in the microchannel, due to an applied electric field. (Column 6, lines 29-33)

Regarding claim 58, Heller et al disclose application of droplets with volume as low as 100 pL. A spherical 100 pL droplet has a diameter of approximately 12 microns, well below the disclosed port diameter.

Regarding claims 61 and 62, Heller et al disclose forming the droplet on, and applying it to the loading port, via a droplet carrying element. (Column 6, lines 20-28)

Relevant to claim 63, Heller et al disclose applying several droplets and applying each to a different port. (Column 6, lines 25-28, Figures 1 and 2)

Heller et al do not explicitly describe the dead volume within the interface ports or whether liquid within the microchannels enters the interface ports, nor do they explicitly describe the ports as having a diameter significantly larger than their depth. Heller is silent concerning the thickness of the cover plate.

Amigo discloses similar microfluidic systems, which use a cover having a thickness as low as 10 microns. (Column 8, lines 1-6)

McCormick et al disclose a microfluidic system in which they cover the channels with a cover as thin as 10 microns. (Column 13, lines 17-22)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the method disclosed by Heller et al by performing it in a device with a cover plate of 10 micron thickness, as taught by either Amigo or McCormick et al, because the silence of Heller et al concerning this indicates that a skilled artisan could choose any suitable cover thickness, such as those known in the prior art, e.g. McCormick et al or Amigo. The choice of thinner material could be motivated by reduction of material consumption, which could potentially reduce manufacturing costs.

Regarding the limitations to specific dead volumes and whether liquid within the channel enters the interface port when the "virtual wall" is formed, such behavior of the

liquid is a function of the affinity of the fluid within the channel for the walls of the port, fluid surface tension, and the respective pressures of the liquid and gas at the interface. There is nothing to physically distinguish the port and microchannel of this combination from that described in the instant specification, therefore, the liquid within the channels of a device as described by the combination above must be considered to behave in the same way as instantly claimed.

11. Claims 1, 42, 47, 48, 56, 58, 63, 64, 66, and 70 are rejected under 35 U.S.C. 103(a) as being unpatentable over Howitz et al.

Regarding claims 1, 42, 64, 66, and 70, Howitz et al disclose a method of injecting a second liquid into a microchannel filled with a first liquid (Figure) comprising: forming a droplet from the second liquid (Figure, droplet 5) and directing the droplet to, and introducing it through a virtual wall formed by the first fluid in a fluid interface port (6) formed in a sidewall of the microchannel (9). (Column 2, line 65 - Column 3, line 34) The meniscus of the first liquid lies in a plane shared by the sidewall (Thin section of FMD chip 1), as shown in the Figure, and can therefore be described as “substantially coplanar”.

Regarding claim 48, Howitz et al disclose the droplet traversing the virtual wall. (Column 3, lines 31-34) As such, its speed and direction must be appropriate.

Regarding claim 56, Howitz et al disclose fluid motion in the microchannel. (Column 2, lines 1-37)

Regarding claim 58, Howitz et al disclose a droplet having a diameter smaller than the fluid interface port. (Figure)

Relevant to claim 63, Howitz et al also suggest introduction of plural fluids through the interface ports of their device. (Column 1; repeated mention of a fluid microdiode permeable to *fluids* (italics added))

Regarding claim 64, Howitz et al disclose a method of injecting a second liquid into a microchannel filled with a first fluid, said method comprising: forming a droplet (5) from the second liquid, introducing said droplet through a virtual wall formed by the first fluid in a fluid interface port (6) formed in a sidewall of the microchannel (9), said fluid interface port having a diameter between about 25 μm and about 100 μm . (Column 2, line 65 - Column 3, line 34)

Howitz et al do not explicitly describe the dead volume within the interface ports, whether fluid within the channel enters the port when the "virtual wall" is formed, or the introduction of a second droplet of a third fluid through a virtual wall in a second interface port, nor do they explicitly describe the ports as having a diameter significantly larger than their depth.

It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the method disclosed by Howitz by performing it in a device wherein the interface port has no dead volume, dead volume of less than a picoliter, or in which fluid does not enter the port, because whether fluid enters the port is simply a function of the affinity of the fluid within the channel for the walls of the port,

fluid surface tension, and the respective pressures of the liquid and gas at the interface. Howitz discusses such variability of meniscus formation (Column 3, lines 25-31), and choice of fluids, pressures, and materials would allow minimization or elimination of the dead volume, and accompanying elimination of fluid entering the port.

In addition, regarding the limitation that the port has a diameter larger than its depth, although the example given by Howitz et al does not meet this limitation, Howitz et al also disclose variation of the depth of the port. (i.e. length of the capillary; Column 2, lines 5-10 and 27-30) Choice of a shorter length such that this limitation is met would have been obvious to a skilled artisan, particularly given the trend toward miniaturization in this art. Regardless, such limitations directed solely to relative dimensions are generally not considered to distinguish claims from the prior art. In *Gardner v. TEC Systems, Inc.*, 725 F.2d 1338, 220 USPQ 777 (Fed. Cir. 1984), *cert. denied*, 469 U.S. 830, 225 USPQ 232 (1984), the Federal Circuit held that, where the only difference between the prior art and the claims was a recitation of relative dimensions of the claimed device and a device having the claimed relative dimensions would not perform differently than the prior art device, the claimed device was not patentably distinct from the prior art device.

Regarding claim 63, it would also have been obvious to one having ordinary skill in the art at the time the invention was made to use the invention of Howitz et al for the introduction of plural fluids to the fluid-filled channel, because it is suggested by Howitz et al and combination of multiple fluids is a common process requirement.

12. Claims 9-12, 14, 20, and 21 are rejected under 35 U.S.C. 103(a) as being unpatentable over Columbus (US 4,302,313) in view of Bjornson et al.

Relevant to claim 9, Columbus discloses a method of filling a microchannel, comprising directing fluid droplets through an interface port in the channel sidewall (Column 13, lines 30-34), such that the liquid traverses the port and enters the interior. (Column 13, line 42 - Column 14, line 16) The port has a depth equal to the thickness of the sidewall. (Figures)

Relevant to claim 10, Columbus discloses the port being a filling aperture. (Column 13, lines 66-68)

Relevant to claims 11 and 12, Columbus discloses a pressure barrier formed in the microchannel to force the liquid in a first direction. (Figure 19, wider zones 220 force fluid to fill narrower portions of the channel) These widened portions can be called, "stopper holes."

Relevant to claim 14, Columbus discloses vent holes through the sidewall. (Column 14, lines 59-68)

Relevant to claim 20, Columbus discloses filling the channel with two fluids introduced into separate filling apertures, each according to the method of claim 9. (Figures 20 a-c; Column 13, line 30 - Column 14, line 16) The sidewall of Columbus (e.g. Figure 2, plate 38) encompasses a hollow interior having a dimension (which reads on "diameter", since the channels are not limited to a circular shape) as low as 60 microns. (Column 7, lines 20-25)

Relevant to claim 21, Columbus discloses introduction of a gelatinous solution that would not be miscible with an introduced sample fluid. (Column 10, lines 4-41)

Columbus does not explicitly disclose a fluid interface port having a dead volume of less than a picoliter or fluid within the channel not entering the port when the channel is filled, nor does he explicitly disclose the filling apertures (e.g. 27) having diameters greater than their depths.

Bjornson et al disclose a device with fluid transfer members (e.g. Figure 10) that comprise a plate (671) with thickness as low as 100 microns and an orifice (630) with diameter as low as 25 microns. (Column 11, lines 54-64; Column 22, lines 28-37) This would correspond to a port volume of about 50 picoliters. The range of orifice diameters preferred by Bjornson et al (Column 11, lines 54-64) includes the microscale dimensions the device of Columbus (Column 7, lines 20-25), and match typical channel dimensions within the system of Bjornson et al. (Column 8, line 64 - Column 9, line 4)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the device of Columbus et al by using thinner plate materials and smaller port diameters that substantially match channel dimensions, as taught by Bjornson et al, because miniaturization of these devices (Columbus is directed to electrochemical analysis of biological fluids) would allow the use of smaller

sample volumes, the advantage of which would have been apparent to a skilled artisan at the time the invention was made, since miniaturization of sensors and fluid-handling devices has long been a goal within this art. A port dead volume of a picoliter or less, the absence of filling liquid from the port once the channel is filled, and formation of a meniscus that is coplanar with the sidewall would occur, dependent upon the affinities of the various surfaces for the fluid, surface tension, volume introduced, etc. In an alternative interpretation, since fluid flows through the entire volume of the port in the filling step (Column 13, line 30 - Column 14, line 15), it is not clear that any portion of the port volume can be considered "dead volume", meeting the limitations of the claims.

Specific to claims 20 and 21, selection of a suitable port size would have been a matter of choice to one having ordinary skill in the art.

Whether the port diameter is substantially larger than its depth is a function of the thickness of plate materials and port diameter, selection of which lies within the level of ordinary skill in the art. In *Gardner v. TEC Systems, Inc.*, 725 F.2d 1338, 220 USPQ 777 (Fed. Cir. 1984), *cert. denied*, 469 U.S. 830, 225 USPQ 232 (1984), the Federal Circuit held that, where the only difference between the prior art and the claims was a recitation of relative dimensions of the claimed device and a device having the claimed relative dimensions would not perform differently than the prior art device, the claimed device was not patentably distinct from the prior art device.

13. Claims 9, 10, 14, 42, and 55 are rejected under 35 U.S.C. 103(a) as being unpatentable over Columbus (US 4,426,451) in view of Bjornson.

Relevant to claim 9, Columbus discloses a method of filling a microchannel (Figures 1 and 2), comprising directing fluid droplets through an interface port in the channel sidewall (Column 5, lines 24-28), such that the liquid traverses the port and enters the interior. (Column 4, line 55 - Column 5, line 43) The port has a depth equal to the thickness of the sidewall. (Figures)

Relevant to claim 10, Columbus discloses the port being a filling aperture. (Column 5, lines 24-28)

Relevant to claim 14, Columbus discloses vent holes through the sidewall. (Figure 2, hole 50)

Relevant to claim 42, Columbus discloses introduction of a second fluid into a microchannel filled with a first fluid by directing a second liquid to a virtual wall formed in an interface port by the first fluid. (Figures 2-3; Column 7, lines 59-60) The meniscus of the fluid within the channel forms in a plane defined by the sidewall (Figure 2), therefore it can be said to be coplanar with the sidewall.

Relevant to claim 55, Columbus discloses this second fluid being immiscible with the first. (Column 7, lines 59-60)

Columbus does not explicitly disclose a fluid interface port having a dead volume of less than a picoliter, none of the filling fluid from the microchannel entering the port after filling, or the port having a diameter larger than its depth.

Bjornson et al disclose a device with fluid transfer members (e.g. Figure 10) that comprise a plate (671) with thickness as low as 100 microns and an orifice (630) with diameter as low as 25 microns. (Column 11, lines 54-64; Column 22, lines 28-37) This would correspond to a port volume of about 50 picoliters.

It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the device of Columbus et al by using thinner plate materials and smaller port diameters, as taught by Bjornson et al, because miniaturization of these devices (Columbus is directed to electrochemical analysis of biological fluids) would allow the use of smaller sample volumes, the advantage of which would have been apparent to a skilled artisan at the time the invention was made, since miniaturization of sensors and fluid-handling devices has long been a goal within this art. A port dead volume of a picoliter or less, or the absence of filling liquid from the port once the channel is filled would occur, dependent upon the affinities of the various surfaces for the fluid, surface tension, volume introduced, etc. In an alternative interpretation, since fluid flows through the entire volume of the port in the filling step (Column 5, lines 24-38), it is not clear that any portion of the port volume can be considered "dead volume", meeting the limitations of the claims.

Whether the port diameter is substantially larger than its depth is a function of the thickness of plate materials and port diameter, selection of which lies within the level of ordinary skill in the art. Applicants' amendment relies upon recitations of relative size as bases for patentability. In *Gardner v. TEC Systems, Inc.*, 725 F.2d 1338, 220 USPQ

777 (Fed. Cir. 1984), *cert. denied*, 469 U.S. 830, 225 USPQ 232 (1984), the Federal Circuit held that, where the only difference between the prior art and the claims was a recitation of relative dimensions of the claimed device and a device having the claimed relative dimensions would not perform differently than the prior art device, the claimed device was not patentably distinct from the prior art device.

14. Claim 13 is rejected under 35 U.S.C. 103(a) as being unpatentable over Columbus (US 4,302,313) and Bjornson et al as applied to claim 11 above, and further in view of Columbus. (US 4,426,451)

Columbus (US 4,302,313) and Bjornson et al disclose a combined method as described above in addressing claim 11.

Neither Columbus (US 4,302,313) nor Bjornson et al explicitly discloses disposition of a hydrophobic patch in the channel to form a pressure barrier (Claim 13).

Columbus (US 4,426,451) discloses using a hydrophobic surface to prevent fluid flow into a region of his device. (Column 8, line 54 - Column 9, line 22)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to further modify the method of Columbus (US 4,302,313) by performing it in a device that uses a hydrophobic surface to control fluid flow, as taught by Columbus (US 4,426,451), because Columbus (US 4,426,451) teaches its effectiveness in preventing flow to undesired areas of the device, which is required in the method of Columbus. (US 4,302,313; Column 14, lines 29-40)

15. Claims 16 and 17 are rejected under 35 U.S.C. 103(a) as being unpatentable over Columbus (US 4,302,313) and Bjornson et al as applied to claim 9 above, and further in view of Kopf-Sill. (US 6,420,143)

Columbus and Bjornson et al disclose a combined method as described above in addressing claim 9.

Neither Columbus nor Bjornson et al explicitly disclose closing the fluid interface port after filling the channel (Claim 16) or closing the port with a fluid encapsulant. (Claim 17)

Kopf-Sill discloses sealing a fluid reservoir in a microfluidic device with mineral oil in order to reduce evaporative losses. (Column 8, lines 25-30)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to further modify the method of Columbus by adding a liquid encapsulant to the fluid inlet port to seal it after the fluid filling step, as taught by Kopf-Sill, because it would reduce evaporation losses and contamination in analyses run for a length of time or at a temperature where they would be a concern.

16. Claims 16, 18, and 19 are rejected under 35 U.S.C. 103(a) as being unpatentable over Columbus (US 4,302,313) and Bjornson et al as applied to claim 9 above, and further in view of Swierkowski.

Columbus and Bjornson et al disclose a combined method as described above in addressing claim 9.

Neither Columbus nor Bjornson et al explicitly disclose closing the fluid interface port after filling the channel (Claim 16) or closing the port with a covering layer or adhered covering layer. (Claims 18 and 19)

Swierkowski discloses sealing fluid reservoirs in a microfluidic device with an adhesive film in order to reduce contamination and evaporative losses. (Column 2, line 67 - Column 3, line 9)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the method of Columbus by covering the fluid inlet ports with an adhesive covering layer in order to seal them after the fluid filling step, as taught by Swierkowski, because it would reduce evaporation losses and contamination in analyses run for a length of time or at a temperature where they would be a concern.

17. Claims 42, 43, 61, and 62 are rejected under 35 U.S.C. 103(a) as being unpatentable over Sundberg in view of Bjornson et al and Howitz et al.

Relevant to claim 42, Sundberg et al disclose a method of introducing a fluid into a microchannel comprising forming a droplet of the fluid and introducing it to the channel via a fluid interface port. (e.g. Embodiment of Figures 2 and 3) Each port is shown as having a depth equal to the sidewall thickness, and a diameter larger than its depth.

Relevant to claim 43, Sundberg et al disclose the fluid port comprising a second port arranged coaxially with the first, directly opposite. (Figures 2 and 3; Column 5, line 64 - Column 6, line 25)

Relevant to claim 61, Sundberg et al disclose forming the droplet on a droplet-carrying element. (Figure 2)

Relevant to claim 62, Sundberg et al disclose applying the droplet to the port with the droplet-carrying element.

Sundberg et al do not explicitly disclose the port having a dead volume of less than about one picoliter, fluid within the channel not entering the port, the droplet being introduced through a virtual wall formed by a fluid already disposed within the channel, or the droplet being introduced to the virtual wall by the droplet-carrying element.

Bjornson et al disclose a device with fluid transfer members (e.g. Figure 10) that comprise a plate (671) with thickness as low as 100 microns and an orifice (630) with diameter as low as 25 microns. (Column 11, lines 54-64; Column 22, lines 28-37) This would correspond to a port volume of about 50 picoliters.

Howitz et al disclose addition of droplets of fluid through a virtual wall into a channel already filled with a fluid.

It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the device of Sundberg et al by using thinner plate materials and smaller port diameters, as taught by Bjornson et al, because miniaturization of these devices would allow the use of smaller sample volumes, the advantage of which would have been apparent to a skilled artisan at the time the

invention was made, since miniaturization of sensors and fluid-handling devices has long been a goal within this art. A port dead volume of a picoliter or less, or the absence of liquid in the port would occur, dependent upon the capillary dimensions, port dimensions, the affinities of the various surfaces for the fluid, surface tension, volume introduced, etc.

It would also have been obvious to one having ordinary skill in the art at the time the invention was made to modify the method of Sundberg et al by introducing the fluid via a virtual wall in the port into a channel already filled with fluid, as taught by Howitz et al, because it would allow facile dosing of additional liquids into the device. The menisci in such a device would be positioned in planes defined by the respective sidewalls, meeting the limitation to these features being "substantially coplanar".

Furthermore, claim 42 relies upon a size limitation as a basis for patentability. In *Gardner v. TEC Systems, Inc.*, 725 F.2d 1338, 220 USPQ 777 (Fed. Cir. 1984), *cert. denied*, 469 U.S. 830, 225 USPQ 232 (1984), the Federal Circuit held that, where the only difference between the prior art and the claims was a recitation of relative dimensions of the claimed device and a device having the claimed relative dimensions would not perform differently than the prior art device, the claimed device was not patentably distinct from the prior art device.

18. Claims 44 and 45 are rejected under 35 U.S.C. 103(a) as being unpatentable over Sundberg et al, Bjornson et al, and Howitz et al as applied to claim 42 above, and further in view of Swedberg et al.

Sundberg et al, Bjornson et al, and Howitz et al disclose a combined method as described above in addressing claim 42.

None among Sundberg et al, Bjornson et al, or Howitz et al explicitly disclose any specific means of detection within their device.

Swedberg et al disclose a microfluidic device that includes apertures through the substrates that define the channels to enable optical detection. (Column 17, line 31 - Column 18, line 18)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the combined method of Sundberg et al, Bjornson et al, and Howitz et al by providing optical detection means with a beam directed at the aperture giving access to the channel interior, as taught by Swedberg et al, because such a beam path would minimize absorbance or distortion by the device material.

19. Claims 44 and 45 are rejected under 35 U.S.C. 103(a) as being unpatentable over Howitz et al in view of Swedberg et al.

Howitz et al disclose a method as described above in addressing claim 42.

Howitz et al do not explicitly disclose any specific means of detection within their device.

Swedberg et al disclose a microfluidic device that includes apertures through the substrates that define the channels to enable optical detection. (Column 17, line 31 - Column 18, line 18)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the method disclosed by Howitz et al by providing optical detection means with a beam directed at the aperture giving access to the channel interior, as taught by Swedberg et al, because such a beam path would minimize absorbance or distortion by the device material.

20. Claims 57, 61, and 62 are rejected under 35 U.S.C. 103(a) as being unpatentable over Howitz et al in view of Sundberg et al.

Howitz et al disclose methods as described above in addressing claim 42 and 56.

Howitz et al do not explicitly disclose causing fluid motion by electric fields (Claim 57), forming the droplet on a droplet-carrying element (Claim 61), or introducing the droplet to the virtual wall on a droplet-carrying element. (Claim 62)

Sundberg et al disclose fluid motion being caused by application of an electric field (Column 6, lines 26-33), formation of droplets on a carrying element prior to introduction to a channel (Figure 2), and introduction of the droplet to the port via the carrying element. (Column 5, lines 32-34)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the method disclosed by Howitz et al by causing fluid motion by application of an electric field, as taught by Sundberg et al, because it is a reliable means of causing fluid motion in a channel.

It would also have been obvious to one having ordinary skill in the art at the time the invention was made to modify the method disclosed by Howitz et al by forming

droplets on pins and introducing the droplets to the ports on these pins, as taught by Sundberg et al, because it is a controllable, reliable fluid transfer means.

Response to Arguments

21. Applicant's arguments filed 7 August 2008 have been fully considered but they are not persuasive.

Applicant argues that adequate support for the limitations is present in the specification, citing Figures 9A and page 21, lines 4-28, as well as page 9, lines 7-10. The Examiner maintains that none of these portions of the specification specifically teach that no fluid enters the fluid interface port. In arguing for support Applicant states "In Figure 9A, the fluid interface port has 'zero dead volume i.e. no liquid is retained in the fluid interface port 17'." It is unclear from where in the specification this quotation may be taken, but it is not from the portions cited in Applicant's remarks.

Applicant argues that no combination of the cited references teaches that none of the liquid in a filled microchannel enters back into the fluid interface port. The Examiner maintains, as throughout prosecution, that Applicant is describing the behavior of fluid within a conventional microfluidic device design, e.g. Heller et al, and that the meniscus will obviously form in Applicant's device in precisely the same manner as in the prior art devices, in the absence of any structural difference between the systems. No arguments or evidence of such distinction have been presented by Applicant.

Any recited limitations that merely describe the way in which a fluid behaves in a channel having a hole in its side are considered unpatentable over the structures and

methods taught, for example, by Heller et al, because the channel/port structures taught by these references are the same as those instantly claimed. Once liquid is added to the channels, the liquid must be considered to behave precisely the same as long as there is no structural difference between the claims and the prior art.

A “virtual wall” is a meniscus - it corresponds to nothing that is not explicitly, implicitly or inherently present in the prior art cited above. Any fluid disposed in a microchannel having a hole in the sidewall will form a meniscus, just as in Applicant’s disclosure. No evidence has been provided to demonstrate a channel structure that is in any way distinct from the prior art as cited above. The prior art teaches microchannels having sidewall holes of the same dimensions as those of the instant claims. Fluid disposed in these channels must be considered to behave in the same way as described in the instant claims because Applicant has demonstrated no patentable difference in the channel and port structures.

Applicant argues that Heller et al teaches an enlarged application area A, maintaining that this teaches away from the claimed dead volume limitation. Applicant further argues that “enlarged” application areas A somehow will result in fluid entering the port from the channel. There is no evidence to support such a position. Fundamentally, both Heller et al and the instant application teach methods involving microfluidic channels having sidewall ports, and direction of droplets to the menisci formed by fluids in the channels. No persuasive evidence has been provided that the channels, ports, or menisci of the instant specification are in any way different from those of the prior art.

Applicant argues that Howitz teaches spreading of the fluid to the capillary ends. The Examiner notes that Howitz et al also teach variability in meniscus formation and variation in capillary length. (Column 3, lines 25-31; Column 2, lines 5-10) The Examiner maintains obviousness of the claims based on these considerations, and the fact that mere differences in size do not confer patentability without difference in operation, as noted in *Gardner v. TEC Systems, Inc.*

Regarding the application of the Columbus '313 reference, Applicant argues that the reference does not teach the limitations regarding the size of the port. The Examiner agrees that Columbus alone does not explicitly teach these limitations. However, the Examiner considers that the picoliter (or less) dead volume would result from the miniaturization of the dimensions of the device of Columbus et al, the feasibility of which is demonstrated by Bjornson et al, who demonstrated micron scale ports in thin plates as described above. As in the case of Howitz et al, the dead volume associated with these ports, or the absence of filling liquid from the port once the channel is filled would be dependent upon the affinities of the various surfaces for the fluid, surface tension, volume introduced, etc. In addition, as pointed out above, given an alternative interpretation of the reference, since fluid flows through the entire volume of the port in the filling step (Column 13, line 30 - Column 14, line 15), it is not clear that any portion of the port volume can be considered "dead volume". Similar reasoning applies to the Columbus '451 reference. Limitations to respective dimensions without a difference in operation cannot be the basis for patentability. As cited above, in *Gardner v. TEC Systems, Inc.*, 725 F.2d 1338, 220 USPQ 777 (Fed. Cir. 1984), *cert. denied*, 469 U.S.

830, 225 USPQ 232 (1984), the Federal Circuit held that changes in size alone do not provide patentability.

Applicant argues the distinction between the claimed ports and those of Bjornson et al. As noted above, Bjornson is relied upon to teach the ability to form ports of micron scale in thin substrates. The channel structure of Bjornson in relation to the ports is not relied upon in the rejections.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Dr. Jeffrey T. Barton whose telephone number is (571)272-1307. The examiner can normally be reached on M-F 9:00AM - 5:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam Nguyen can be reached on (571) 272-1342. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Jeffrey T. Barton/
Art Unit 1795
7 November 2008